SEP 1 5 2003 SEE

Thereby certify that this correspondence is being deposited with the United States Postal Service on the date set forth below as First Class Mail in an envelope addressed to: Mail Stop Non-Fee Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Signature and Deposit: September 10, 2003

Attorney of Record

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Richard D. Harris, et al.

Serial No.:

09/842,975

Filed:

04/26/2001

Examiner:

Eric W. Thomas

Group Art Unit:

2831

Docket No.:

110003.97397

Title:

Method for Fabricating an Isolated Microelectromechanical System

(MEMS) Device Incorporating a Wafer Level Cap

## **AMENDMENT**

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated July 10, 2003, please amend the above-identified patent application as follows and consider the following remarks: